

Application/Control No	Applicant(s)/Patent un Reexamination	Applicant(s)/Patent under Reexamination	
10/684,379	KOBAYASHI, TAKAS	KOBAYASHI, TAKASHI	
Examiner	Art Unit		
Kevin Quinto	2826		

Subclass	Date	Examiner
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
257 (314, 315, 316, 317, 318, 34, 320, 321, 322 438/201, 21, 257, 266 (text limited - see prindend)	10[13] 16[14] 16[15] 16[15]	H		
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